



Attorney Docket No.:SAM-0526
Application Serial No.: 10/796,507
Reply to Office Action of: June 13, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Ki Hwan Park, *et al* Examiner: El Arini, Zeinab
Serial No.: 10/796,507 Group Art Unit: 1746
Filing Date: March 9, 2004
Title: METHOD OF RINSING AND DRYING SEMICONDUCTOR
SUBSTRATES (As Amended)

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the United States Post Office as First Class Mail in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

10/11/06
Date

Christina Harris

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT C

Sir:

The following is in response to the Office Action dated June 13, 2006. A petition for a one-month extension of the time period in which to respond is filed concurrently herewith.

Please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.